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Docket No. 8733.1014.00  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Oh-Nam KWON

Customer No. 30827

Application No. 10/786,038

Confirmation No. 2919

Filed: February 26, 2004

Art Unit: 2818

For: MANUFACTURING METHOD OF ELECTRO  
LINE FOR SEMICONDUCTOR DEVICE

Examiner: David Vu

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AFTER FINAL OFFICE ACTION**

Sir:

In response to the final Office Action dated December 26, 2006, please amend the patent application identified above as follows:

**INTRODUCTORY COMMENTS**

**Amendments to the Claims** are reflected in the listing of claims that begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.